

PTO-1449 Information Disclosure Citation in an Application	Application No. 09/895,525	Applicant(s) Manoel Tenorio		
	Docket Number 020431.0843	Group Art Unit 2171	Filing Date June 28, 2001	

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U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A	2001/0044751 A1	11/22/2001	Pugliese, III et al.	705	26	04/03/2001
B	6,343,287 B1	01/29/2002	Kumar et al.	707	4	05/19/1999
C	2002/0026386 A1	02/28/2002	Walden	705	27	06/13/2001
D	2002/0046187 A1	04/18/2002	Vargas et al.	705	67	04/02/2001
E	2002/0123955 A1	09/05/2002	Andreski et al.	705	37	12/28/2000
F	2003/0195877 A1	10/16/2003	Ford et al.	707	3	03/31/2003
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